

**PATENT**  
Attorney Docket No. 211843-00035

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

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Application No.: 10/825,339  
Filing Date: April 15, 2004  
Inventor(s): Thomas Neil Horsky  
Group Art Unit: 2881  
Examiner Name: Jack I Berman  
Customer No.: 27160  
Title: ION IMPLANTATION ION SOURCE,  
SYSTEM AND METHOD

Confirmation No.: 8637

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**FAX RECEIVED**

JUL 01 2005

**OFFICE OF PETITIONS**

**AMENDMENT**

Sir:

In accordance with the concurrently filed Petition under 37 C.F.R. 1.78, please enter the following amendment:

**Amendments to the specification are reflected on page 2 of this paper.**

**Remarks/Arguments begin on page 3 of this paper.**